

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
CHOU, Ming-Chun et al.

Serial No.: Herewith

Filed: Herewith

For: BRUSH POSITIONING
DEVICE FOR A WAFER
CLEANING STATION

Group Art Unit: TBA
Examiner: TBA

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT

In accordance with the rules relating to the duty of disclosure, 37 CFR §1.56 and §1.97, Applicants submit herewith Form PTO-1449 and copies of the references listed therein.

Applicants believe that no fee is due at this time, since an Official Action has not yet been received. If, however, a fee is deemed due, authority is hereby given to charge such fee to Deposit Account No. 50-2061.

Consideration and entry of these references is respectfully requested.

Respectfully submitted,

[Signature]

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April 14, 2004

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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

N1161-00026

Application Number

Filed Herewith

Applicant(s)

Ming-Chun Chou et al.

Filing Date

Filed Herewith

Group Art Unit

TBA

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	5,475,889	12/19/95	Thrasher et al.	15	88.3	07/15/94
	B	5,947,134	09/07/99	Kim et al.	134	57R	09/15/97

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.